



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : N. Sakamoto et al.

Art Unit : 2815

Serial No. : 09/810,101

Examiner : Sheila Clark

Filed : March 16, 2001

Title : RADIATION SUBSTRATE AND SEMICONDUCTOR MODULE

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 10, 2003

Please amend the above-identified application as follows:

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TECHNOLOGY CENTER 2800

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 10, 2004

Date of Deposit

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